

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE RECEIVED

In re Application of:)	Examiner: H. Nguyen	MAR 1 2 2004
Yuji SUDOH et al.)	Group Art Unit: 2851	
Application No.: 09/532,022)	Group The Ome. 2001	
Filed: March 21, 2000)		
For: EXPOSURE APPARATUS AND A DEVICE MANUFACTURING METHOD WHICH KEEP TEMPERATURE OF A DIAPHRAGM OF A PROJECTION OPTICAL SYSTEM SUBSTANTIALLY CONSTANT) :) :	March 9, 2004	

Mail Stop Non-Fee Amendment

The Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

<u>AMENDMENT</u>

Sir:

In response to the Office Action dated December 12, 2003, please amend the above identified application as follows.